Application/Control No.	Applicant(s)/Patent under Reexamination	
10/775,431	OVSHINSKY ET AL.	
Examiner	Art Unit	
Eric Wendler	2824	

SEARCHED					
Class	Subclass	Date	Examiner		
365	163	8/30/2005	EJW		
257	2	9/9/2005	EJW		
	,				
			,		
	,				
<u> </u>					

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
			·		
		•			

	SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR			
Consulted with Primary Examiner Van Thu Nguyen on Class 365	8/30/2005	EJW			
Consulted with Primary Examiner Anh Phung on Class 257	9/9/2005	EJW			
See attached EAST search history	9/9/2005	EJW			
		,			
		-			